



DOCKET NO: 245166US3CIP

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TSUTOMU OKABE, ET AL.

: EXAMINER: MOORE, K.

SERIAL NO: 10/706,977

:

RCE FILED: HEREWITH

: GROUP ART UNIT: 1763

FOR: WAFER PROCESSING  
APPARATUS HAVING DUST PROOF  
FUNCTION

:

AMENDMENT FILED WITH RCE

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated November 16, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

04/18/2006 FFANAEIA 00000091 10706977  
02 FC:1801 790.00 BP